Features of a micro GC based on Sorptive Extraction and Microchip Plasma Emission Detection (PED) for the Analysis of Harmful and Toxic Substances in Air





Research Institute For Chromatography



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| Selectivity/sensitivity data | | | | | |
|------------------------------|----------------------------------|---|-------------------------------|---|--|
| Element (X) | Selective wavelengths (nm) | Element to carbon selectivity (g X / g C) | Sensitivity (absolute qty) | Compounds tested | |
| С | 551, 558 *, 430 (CH) | n.a. | 100 pg | alkanes, aromatics | |
| CI | 837 *, 858 | 10-30 | 100 pg 100 pg 500 pg | 2-chloroethyl ethylsulfide (CEES) 1,2-dichloroethane 1,3-dichloro-2-propanol Trichlorobenzene chloronaphthalene chlorpyrifos | |
| Br | 882 *, 889 | 10 | 1 ng | 1,2-dibromoethane bromobenzene 1-bromonaphthalene | |
| F | 740* | 200 | 100 pg | Fluorobenzene 1-fluoronaphthalene 4-ethoxytrifluoro-3-butenone | |
| Hg | 254 *, 365 | >> | 100 pg | di-methylmercury | |











| | µCAD conditions |
|--|--|
| Sample | - 0.66 μg/L B, T, E, m-X, ο-X, p-X in air |
| Sampling | 30 sec @ 110 mL/min (vial 1.1 times flushed) |
| Chemical trap | Carbotrap B |
| Thermal desorption | 200°C (40 sec) |
| GC column | 5 m x 250 µm I.D., 1 µm df HP1-MS |
| Carrier gas | Helium, constant pressure @ 7.5 psi (52 kPa) |
| GC column temp | 35°C (3 min) |
| PED | Time acquisition: CH A 8nm, CH B 558nm, CH C 254nm, CH D 258nm, CH E 833nm, CH F 685nm, USB4000 Integration time 50 msec, Avg 1/10 |
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| Sample | 10 μL per compound injected in 20 mL vial and equilibrated at 80°C 10 μL vapor injected in heated (150°C) 10 mL sampling valve | | |
|--------------------|---|--|--|
| Sampling | 10 sec @ 200 mL/min (sample vial 2 times flushed) | | |
| Chemical trap | Tenax TA | | |
| Thermal desorption | 200°C (40 sec) | | |
| GC column | 5 m x 250 µm I.D., 1 µm df HP1-MS – connected to FID/PED/IMS/µECD | | |
| Carrier gas | Helium, constant pressure @ 7.5 psi (52 kPa) | | |
| GC column temp | 35°C (3 min) – 5°C/min – 150°C | | |
| FID | 280°C, air 350mL/min, H2 35 mL/min | | |
| PED | Time acquisition: 248nm, 558nm, 254nm, 258nm, 833nm, 685nm, USB4000 Integration time 100, Avg 0 | | |
| IMS | 500 mL/min air, 115°C, scanning Vc -15 to +5V, RF 600V | | |
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